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Docket No.: 04970/0204683-US0 (PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Yasuyuki Hayashi et al.

Application No.: National Phase of

PCT/JP2004/017725

Filed: Concurrently Herewith Art Unit: N/A

For: PLASMA GENERATOR AND PLASMA

ETCHING APPARATUS

MI CIIII. 14/11

Examiner: Not Yet Assigned

Confirmation No.: N/A

## INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement accompanies the new patent application submitted herewith.

A summary/abstract translation of the non-English language documents is enclosed.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information

Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Commissioner is authorized to charge any deficiency of up to \$300.00 or credit any excess in this fee to Deposit Account No. 04-0100.

Dated: June 1, 2006

Respectfully submitted

Louis J. DelJuidice

Registration No.: 47,522 DARBY & DARBY P.C.

P.O. Box 5257

New York, New York 10150-5257

(212) 527-7700

(212) 527-7701 (Fax)

Attorneys/Agents For Applicant

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Substitute for form 1449A/B/PTO				Complete If Known		
				Application Number	Not Yet Assigned	
INFORMATION DISCLOSURE				Filing Date	Concurrently Herewith	
STATEMENT BY APPLICANT			PPLICANT	First Named Inventor	Yasuyuki Hayashi	
<b>4 2</b>				Art Unit	N/A	
	(Use as many sheets as necessary)			Examiner Name	Not Yet Assigned	
Sheet	1	of	1	Attorney Docket Number	04970/0204683-US0	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Document Number  Number-Kind Code <sup>2</sup> ( if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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FOREIGN PATENT DOCUMENTS							
Examiner	Cite	Foreign Patent Document	Publication	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
initials*	No.	Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	Date MM-DD-YYYY			T <sup>6</sup>	
/LA/	ВА	JP-07-320894-A	12-08-1995	MATSUSHITA ELECTRIC IND COLTD	Abstract Attached	<b>√</b>	
/LA/	ВВ	JP-2000-030893-A	01-28-2000	MITSUBISHI HEAVY IND LTD	Abstract Attached	4	
/LA/	ВС	JP-10-270193-A	10-09-1998	NICHIMEN DENSHI KOKEN KK; UTEC:KK	Abstract Attached	√	
/LA/	BD	JP-2003-224110-A	08-08-2003	FUJITSU LTD; FUJITSU VLSI LTD	Abstract Attached	1	
/LA/	BE	JP-10-149788-A	06-02-1998	HITACHI LTD	Abstract Attached	1	
/LA/	BF	JP-2003-234293-A	08-22-2003	CANON INC	Abstract Attached	4	

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